

PATENT ASSIGNMENT

Electronic Version v1.1

Stylesheet Version v1.1

SUBMISSION TYPE:	CORRECTIVE ASSIGNMENT
NATURE OF CONVEYANCE:	Corrective Assignment to correct the Application number: 10/765,697 previously recorded on Reel 020785 Frame 0396. Assignor(s) hereby confirms the Correct Application number: 10/675,697.
CONVEYING PARTY DATA	
Name	Execution Date
Mr. Jui-Lung Li	04/08/2008
RECEIVING PARTY DATA	
Name:	Hitachi Global Storage Technologies
Street Address:	5600 Cottle Road
Internal Address:	Intellectual Property Law Department
City:	San Jose,
State/Country:	CALIFORNIA
Postal Code:	95193
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	10765697
CORRESPONDENCE DATA	
Fax Number:	(312)475-1850
<i>Correspondence will be sent via US Mail when the fax attempt is unsuccessful.</i>	
Phone:	312-222-1860
Email:	joskorep@securepatents.com
Correspondent Name:	John J. Oskorep, Esq. LLC
Address Line 1:	980 North Michigan Avenue
Address Line 2:	Suite 1400
Address Line 4:	Chicago, ILLINOIS 60611
ATTORNEY DOCKET NUMBER:	HSJ9-2003-0032US1
NAME OF SUBMITTER:	John J. Oskorep, Esq.
Total Attachments: 2	

CH \$40.00 10765697

500511952

PATENT  
REEL: 020791 FRAME: 0627



PATENT ASSIGNMENT

Electronic Version v1.1  
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04/10/2008  
 500510788

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT
CONVEYING PARTY DATA	
Name	Execution Date
Mr. Jui-Lung Li	04/08/2008
RECEIVING PARTY DATA	
Name:	Hitachi Global Storage Technologies
Street Address:	5600 Cottle Road
Internal Address:	Intellectual Property Law Department
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Address Line 1:	980 North Michigan Avenue
Address Line 2:	Suite 1400
Address Line 4:	Chicago, ILLINOIS 60611
ATTORNEY DOCKET NUMBER:	HSJ9-200300032US1
NAME OF SUBMITTER:	John J. Oskorep, Esq.
Total Attachments: 2 source=Assignment Jui-Lung Li#page1.tif source=Assignment Jui-Lung Li#page2.tif	

CH \$40.00 10765697

ASSIGNMENTINVENTOR  
AND CITY

Whereas, I,

Jui-Lung Li, of San Jose, County of Santa Clara, State of California,

have invented certain improvements in

TITLE

METHOD OF FORMING A READ SENSOR USING PHOTORESIST STRUCTURES WITHOUT UNDERCUTS WHICH  
ARE REMOVED USING CHEMICAL-MECHANICAL POLISHING (CMP) LIFT-OFF PROCESSESDATES THAT  
INVENTORS  
SIGNED THE

and executed, respectively, a United States patent application therefor on

(1) 4/8/2008 (2) \_\_\_\_\_ (3) \_\_\_\_\_ (4) \_\_\_\_\_

Whereas, HITACHI GLOBAL STORAGE TECHNOLOGIES NETHERLANDS, B.V., having a place of business at Locatellikade 1, 1076 AZ Amsterdam, The Netherlands (hereinafter called HITACHI), desires to acquire the entire right, title and interest in the said application and invention, and to any United States and foreign patents to be obtained therefor;

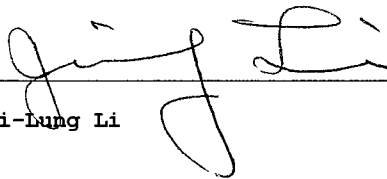
Now therefore, for a valuable consideration, receipt whereof is hereby acknowledged, we, the above named, hereby sell, assign, and transfer to HITACHI, its successors and assigns, the entire right, title and interest in the said application and invention therein disclosed for the United States and foreign countries, and all rights of priority resulting from the filing of said United States application, and we request the Commissioner of Patents to issue any Letters Patent granted upon the inventions set forth in said application to HITACHI, its successors and assigns; and we hereby agree that HITACHI may apply for foreign Letters Patent on said invention and we will execute all papers necessary in connection with the United States and foreign applications when called upon to do so by HITACHI.

Signed and sealed

CITY

(1) at San Jose

DATE

on April 8, 2008


SIGNATURE

Jui-Lung Li

INVENTOR